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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Response Under 37 CFR 1.116 - Expedited Procedure
Customer Number: 20277

Kenji YONEDA

Confirmation Number: 9901

Application No.: 10/774,522

Group Art Unit: 2891

Filed: February 10, 2004

Examiner: SARKAR, Asok K.

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	23	23	0	\$50.00 =	\$0.00
Independent Claims	5	5	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: March 1, 2006Please recognize our Customer No. 20277 as our
correspondence address.



Docket No.: 060188-0768

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Response under 37 C.F.R. § 1.116
	:	<u>Expedited Procedure</u>
Kenji YONEDA	:	
	:	Customer Number: 20277
Application No.: 10/774,522	:	Confirmation Number: 9901
	:	
Filed: February 10, 2004	:	Group Art Unit: 2891
	:	Examiner: SARKAR, Asok K.

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR
DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 1, 2005, having a three-month shortened statutory period for reply set to expire on March 1, 2006, please amend the above identified patent application as follows.